



648.42568VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: G. MIYA et al
Serial No.: 10/779,742
Filed: February 18, 2004
For: Plasma Processing Method
Art Unit: 1763
Examiner: R. Kackar

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 12, 2006

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated January 12, 2006 and the interview conducted on April 25, 2006. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.